- Park				. [8]	U	.s. uti L			Applicat	ion	. L.			
O.I.P.E. PATENT DATE														
						SCANNED SS Q.A. WI								
D	APPLICA IO. CONT/PRIOR					CLASS SUBCLASS ART UNIT EXAMINER								
•	09/6 2969 D					118 -1734 CL March Lhis							, D^	
	•	LICANTS	ur j ≜ 1	Doan 4		esi a		الظاهبإاا					·	
		OLS.	Ą.											
Chemical dispensing system for semicond										tor wafer processing				
		THE									•		PTO-2040 12/99	
The second secon												5. m		
ISSUING CLASSIFICATION														
	ORIGINAL					CROSS REFERENCE(S) CLASS SUBCLASS (ONE SUBCLASS PER BLOC						N OCK		
	CLASS SUBCLASS				-	CLASS		730	CLASS (OF	IE SUBCL	188 PER C	SLOCK)		
	INTERNATIONAL CLASSIFICATIO			ON	180									
	P	050	11	102-	. 1	r)		1 25 12.	
			-										<u> </u>	
. /	_		+-											
561.8 234						Continued on tesue Slip Inside File Je						acket		
									1					
-4					DRAWINGS Sheets Drwg. Figs. Drwg. Print Fig.			-	CLAIMS ALLOWED					
•				: ·				10tal						
 	L								NOTICE OF ALLOWANCE MAILED					
	The term of this patent subsequent to					SYLVIA R. MACARTHUR S/14/03								
<i>y</i> .					١					10.30	න <u> </u>	, w		
4 √ -					GREGORY MILLS SUPERVISORY PATENT EXAMINER TECH:OLOGY CENTER 1700					ISSUE FEE				
									Amo	unt Due	Dat	e Paid		
•					h 2 / 1 / (r - 7)				\$ 1330					
#	The terminalmonths of				MAN 1013102			· ·	ISSUE BATCH NUMBER					
	this patent have been disclaimed.				(Legal Instru	ments E	miner)	(Date)	<u></u>		√ n 1993	e de la companya de l		
٠	14	WARNIN	G:	sed herein may be n		*			4.	,				